

Notice of References Cited

Application/Control No.

09/810,828

Applicant(s)/Patent Under

Reexamination

ZARRABIAN ET AL.

Examiner

Thomas R Artman

Art Unit

2882

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U.S. PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Name	Classification
	A	US-5,343,542	08-1994	Kash et al.	356/454
	B	US-5,144,498	09-1992	Vincent, Kent D.	250/226
	C	US-			
	D	US-			
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	K	US-			
	L	US-			
	M	US-			

FOREIGN PATENT DOCUMENTS

*		Document Number Country Code-Number-Kind Code	Date MM-YYYY	Country	Name	Classification
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NON-PATENT DOCUMENTS

*		Include as applicable: Author, Title Date, Publisher, Edition or Volume, Pertinent Pages)
	U	Takashashi, Haruo. "Temperature stability of thin-film narrow-bandpass filters produced by ion-assisted deposition." <input type="checkbox"/> Applied Optics, Vol. 34, No. 4, Feb.1, 1995, pp.667-675
	V	
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	X	

*A copy of this reference is not being furnished with this Office action. (See MPEP § 707.05(a).)

Dates in MM-YYYY format are publication dates. Classifications may be US or foreign.